

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE 1-31-02

Priority Application Serial No	09/475,545
Priority Filing Date	
Inventor	
Assignee	Micron Technology, Inc.
Priority Group Art Unit	3723
Priority Examiner	G. Nguyen
Attorney's Docket No	MI22-1881
Title: Chemical-Mechanical Polishing Methods	

PRELIMINARY AMENDMENT

To:

Box PATENT APPLICATION

Assistant Commissioner for Patents

Washington, D.C. 20231

From:

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AMENDMENTS

In the Specification

At p. 1, before the "Technical Field" section, insert

--RELATED PATENT DATA

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This patent resulted from a divisional application of U.S. Patent Application Serial No.

09/475,545, filed on December 30, 1999.--

In The Claims

Please cancel claims 1-25 and 39-70 without prejudice.

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